



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

SASAKI

Serial No. 09/487,259 ✓

Filed: January 19, 2000

For: METHOD FOR MANUFACTURING A
SEMICONDUCTOR DEVICE BY PARTIALLY
DICING A SUBSTRATE AND SUBSEQUENT
CHEMICAL ETCHING

Confirmation No. 2949

Allowed: December 19, 2003

Atty Ref.: 1035-243

Group: 2814

Examiner: A. Mai

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January 7, 2004

Mail Stop PGPUB Drawings
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION OF FORMAL DRAWINGS

Sir:

As required by the Notice of Allowability dated December 19, 2003, enclosed
herewith are seventeen (17) sheet(s) of formal, inked drawings for the above-identified
application.

Respectfully submitted,

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